

Docket No.: 21776-00042-US1  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Nobuhiro Miki et al.

Application No.: 10/656,190

Confirmation No.: 8417

Filed: September 8, 2003

Art Unit: 1746

For: SURFACE PURIFICATION APPARATUS  
AND SURFACE PURIFICATION METHOD

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Examiner: M. Kornakov

**AMENDMENT FILED WITH REQUEST FOR CONTINUED EXAMINATION (RCE)**

**MS RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action mailed May 10, 2007 and Advisory Action mailed August 15, 2007, please amend the above referenced application as follows:

**Amendments to the Claims** are reflected in the Listing of Claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.